



The Silicon Pixel Detector (SPD) for the ALICE Experiment

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ALICE

ALICE Layout: the ITS and the SPD

Silicon Pixel Detector



B-field < 0.5 T
Charged particle multiplicities of up to 8000 per unit of rapidity (head-on Pb-Pb collisions)

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The ALICE SPD



- Secondary vertexing capability (c,b)
- Track impact parameter resolution: $r\varphi$ < 50 μm (pt >1.3 GeV/c)
- Two barrel layers: $R_i = 39 \text{ mm}$, $R_o = 76 \text{ mm}$
- Inner layer pseudorapidity coverage: $|\eta| < 1.95$ [ITS coverage $|\eta| \approx 0.8$]
- Total Si surface: ≈ 0.24 m²
- Individual pixel cell: 50 μ m (r ϕ) x 425 μ m (z)
- Occupancy (central Pb-Pb): < 2%



Track densities at r = 4 cm (1st pixel layer): up to 100/cm²

• Radiation level at the inner layer for 10 years standard running: TID \approx 5kGy, F \approx 6.10¹² (1MeV n_{eq})/cm² (working values!)





SPD Mounting





Carbon Fiber Support Sector (CFSS)

Material budget (each layer): ≈ 0.9% X₀ (Si \approx 0.37, cooling \approx 0.3, bus \approx 0.17, CFSS \approx 0.1) V. Manzari - Quark Matter 2004 - Oakland

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- FE power dissipation/sector: ≈ 150 W
- Cooling: C_4F_{10} (evaporative), operating temperature $\approx 25^{\circ}C$
- Cooling test with a prototype module is currently under way



ALICELHCb1 Pixel ASIC







- Mixed signal (analogue, digital)
- Produced in a commercial 0.25µm CMOS process (8" wafers)
- Radiation tolerant design (enclosed gates, guard rings)
- 8192 pixel cells
- 50 μ m (r ϕ) x 425 μ m (z) pixel cell
- ~100 µW/channel
- ~1000 e⁻ mean threshold (~200 e⁻ RMS)
- ~120 e⁻ mean noise

Fisica Nucleare

VTT Bump-Bonding





Fisica Nucleare

- VTT/Finland
- Pb-Sn solder bumps: ~25µm diameter
- p-in-n silicon sensor: 200µm thick (Canberra)
- IBM readout chips: 750µm native thickness thinned to 150µm after bump deposition
- stand-off: ~20µm (Pb-Sn)





SPD Ladder



- 1 p-in-n sensor (200µm thick)
- 5 readout chips (150µm thick)
- 4960 bump bonds
- I_{det} @50V=120-200nA, V_{fd}=15V

Sr-Measurements :

Working pixels Missing pixels

150

100

50



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SPD Multilayer Bus



- + 5 layer Al-Kapton flex 240 μm thick
- wire bonds to the readout chips and MCM
- provides data -, control- and power-lines between readout chips and MCM





- ~1100 Wire bonds/half-stave
- 25µm diameter wire
- Bonding pads on the bus: $80 \times 300 \mu m^2$
- Step height: 40-60µm







Half-stave Assembly (II)





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Barrel Sector Assembly System (I)





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Barrel Sector Assembly System (II)





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2003 Beam Test Setup







- Up to 6 planes (= 5 singles + half stave) in the beam (up to 122 880 active pixels)
- Plane 0 Plane 3 distance ≈ 80 cm, vertically adjusted for tracking
- Target: 4 mm Pb
- Trigger: quartz counter (beam) + 2 cm x 2 cm scintillator (interactions)
- Half-stave read out through MCM including optical module
- 2.8 GB of data collected
- DCS (PVSS) system for HV





Indium Ion Beam on Single Assembly



Beamspot (32V sensor bias) 10⁴ ions/spill



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Summary



- Challenging constraints on geometry and material budget.
- Specific technology developments and extensive tests of the SPD components have been carried out.
- Half-stave and Sector assembly procedures have been developed and tests with dummy components are currently being completed.
- Construction of prototypes with real components has been started: a half-stave with real ladders has been delivered for cooling test, a halfstave for the validation of the multilayer bus with working ladders is under construction.
- SPD components have been tested in a heavy-ion beam (October 2003): offline analysis of collected data ongoing.